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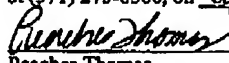
Docket No. 740756-2709

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Koichiro TANAKA) Confirmation No. 9528
Application No. 10/769,820) Examiner: Samuel Heinrich
Filed: February 3, 2004) Group Art Unit: 1725
For: LASER IRRADIATION STAGE, LASER)
IRRADIATION OPTICAL SYSTEM, LASER) Date: April 24, 2007
IRRADIATION APPARATUS, LASER)
IRRADIATION METHOD, AND METHOD)
OF MANUFACTURING A)
SEMICONDUCTOR DEVICE)

AMENDMENT AFTER FINAL

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I hereby certify that this correspondence is being
facsimile transmitted to the USPTO
at (571) 273-8300, on April 24, 2007

Peaches Thomas

Sir:

In response to the Office Action mailed January 24, 2007, please amend the
above-identified patent application as follows.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 8 of this paper.